

L Number	Hits	Search Text	DB	Time stamp
1	235	(438/674).CCLS.	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/07/12 10:10
2	1	((438/674).CCLS.) and (((438/612) or (438/613) or (438/614)).CCLS.) and (electrolyt\$2 same (ni or nickel))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/07/12 10:10
-	2	interconnect and pad and (electrolyt\$2 near7 (ni or nickel)) and (resist or photoresist) and ((front and back) near5 (substrate or wafer))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/07/10 19:12
-	182	(front\$4 near5 (substrate or wafer)) and (back\$4 near5 (substrate or wafer)) and (electrolyt\$3 same (nickel or ni))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/07/10 19:18
-	229	(front\$4 near5 (substrate or wafer)) and ((back\$4 or rear) near5 (substrate or wafer)) and (electrolyt\$3 same (nickel or ni))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/07/10 19:33
-	35	((front\$4 near5 (substrate or wafer)) and ((back\$4 or rear) near5 (substrate or wafer)) and (electrolyt\$3 same (nickel or ni))) and (pad same (front\$4 near5 (substrate or wafer))) and (pad same ((back\$4 or rear) near5 (substrate or wafer)))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/07/10 19:20
-	18	((front\$4 near5 (substrate or wafer)) and ((back\$4 or rear) near5 (substrate or wafer)) and (electrolyt\$3 same (nickel or ni))) and (pad same (front\$4 near5 (substrate or wafer))) and (pad same ((back\$4 or rear) near5 (substrate or wafer))) and (pad same (resist or photoresist))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/07/10 19:26
-	14737	((438/107) or (438/108) or (438/128) or (438/129) or (438/612) or (438/613) or (438/614) or (438/617) or (257/777) or (257/778) or (257/779) or (257/780) or (257/781) or (257/782) or (257/784) or (257/786)).CCLS.	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/07/10 19:33
-	224	"6" and (front\$4 near5 (substrate or wafer)) and ((back\$4 or rear) near5 (substrate or wafer)) and (electrolyt\$3 same (nickel or ni))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/07/10 19:34
-	12	((438/107) or (438/108) or (438/128) or (438/129) or (438/612) or (438/613) or (438/614) or (438/617) or (257/777) or (257/778) or (257/779) or (257/780) or (257/781) or (257/782) or (257/784) or (257/786)).CCLS.) and (front\$4 near5 (substrate or wafer)) and ((back\$4 or rear) near5 (substrate or wafer)) and (electrolyt\$3 same (nickel or ni))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/07/10 19:38
-	29	((438/107) or (438/108) or (438/128) or (438/129) or (438/612) or (438/613) or (438/614) or (438/617) or (257/777) or (257/778) or (257/779) or (257/780) or (257/781) or (257/782) or (257/784) or (257/786)).CCLS.) and ((front\$4 or top) near5 (substrate or wafer)) and ((back\$4 or rear) near5 (substrate or wafer)) and (electrolyt\$3 same (nickel or ni))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/07/10 19:38

-	17	(((438/107) or (438/108) or (438/128) or (438/129) or (438/612) or (438/613) or (438/614) or (438/617) or (257/777) or (257/778) or (257/779) or (257/780) or (257/781) or (257/782) or (257/784) or (257/786)).CCLS.) and ((front\$4 or top) near5 (substrate or wafer)) and ((back\$4 or rear) near5 (substrate or wafer)) and (electrolyt\$3 same (nickel or ni))) not (((438/107) or (438/108) or (438/128) or (438/129) or (438/612) or (438/613) or (438/614) or (438/617) or (257/777) or (257/778) or (257/779) or (257/780) or (257/781) or (257/782) or (257/784) or (257/786)).CCLS.) and (front\$4 near5 (substrate or wafer)) and ((back\$4 or rear) near5 (substrate or wafer)) and (electrolyt\$3 same (nickel or ni)))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/07/10 19:44
-	4467	((438/612) or (438/613) or (438/614)).CCLS.	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/07/10 19:45
-	92	(((438/612) or (438/613) or (438/614)).CCLS.) and (electrolyt\$2 same (ni or nickel)))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/07/12 10:10
-	71	(((438/612) or (438/613) or (438/614)).CCLS.) and (electrolyt\$2 same (ni or nickel))) and (resist or photoresist)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/07/12 10:07